

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L9	24567	PECVD or ((PE or (plasma adj enhanc\$4)) adj3 (CVD or (chemical adj vapor adj deposit\$4)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/27 17:04
L10	927	9 with (dual multi\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/27 17:04
L11	51	10 with (silicon adj nitride SiN)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/27 17:06